



MS-AF
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Neil S CASA

Serial No.: 10/007,618

Filed: November 7, 2001

For: System And Method For Inhibiting Motion Of
Semiconductor Wafers In A Variable-Pressure
Chamber

Examiner: Thuy Van TRAN
Group Art: 3652

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 19, 2005

(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

December 19, 2005

Date of Signature

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

SIR:

PETITION

Applicants hereby petition for a two-month extension of the original shortened statutory response period set in the Office Action of June 17, 2005. Please charge the amount of \$510.00 (**Small Entity**) in payment of the government fee for a three-month extension of time so that the period for response is extended to December 17, 2005 (Saturday). Any additional fees or charges required at this time in connection with the present application may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

RESPONSE

In response to the Final Office Action dated June 17, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 19 of this paper.